



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **HORIBE, Masahiro, et al.**

Group Art Unit: **2811**

Serial No.: **10/809,924**

Examiner: **Not Yet Assigned**

Filed: **March 26, 2004**

**P.T.O. Confirmation No.: 6759**

For. **HIGH-TEMPERATURE SUPERCONDUCTING DEVICE AND MANUFACTURING METHOD THEREOF**

**CLAIM FOR PRIORITY UNDER 35 U.S.C. 119**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Date: July 21, 2004

Sir:

The benefit of the filing date of the following prior foreign application is hereby requested for the above-identified application, and the priority provided in 35 U.S.C. 119 is hereby claimed:

**Japanese Appln. No. 2003-089776, filed March 28, 2003**

In support of this claim, the requisite certified copy of said original foreign application is filed herewith.

It is requested that the file of this application be marked to indicate that the applicants have complied with the requirements of 35 U.S.C. 119 and that the Patent and Trademark Office kindly acknowledge receipt of said certified copy.

In the event that any fees are due in connection with this paper, please charge our Deposit Account No. 01-2340.

Respectfully submitted,

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